

Open Now
1st March 2011 – 31st August 2011

EUMINAfab: Fourth call for applications to no fee access

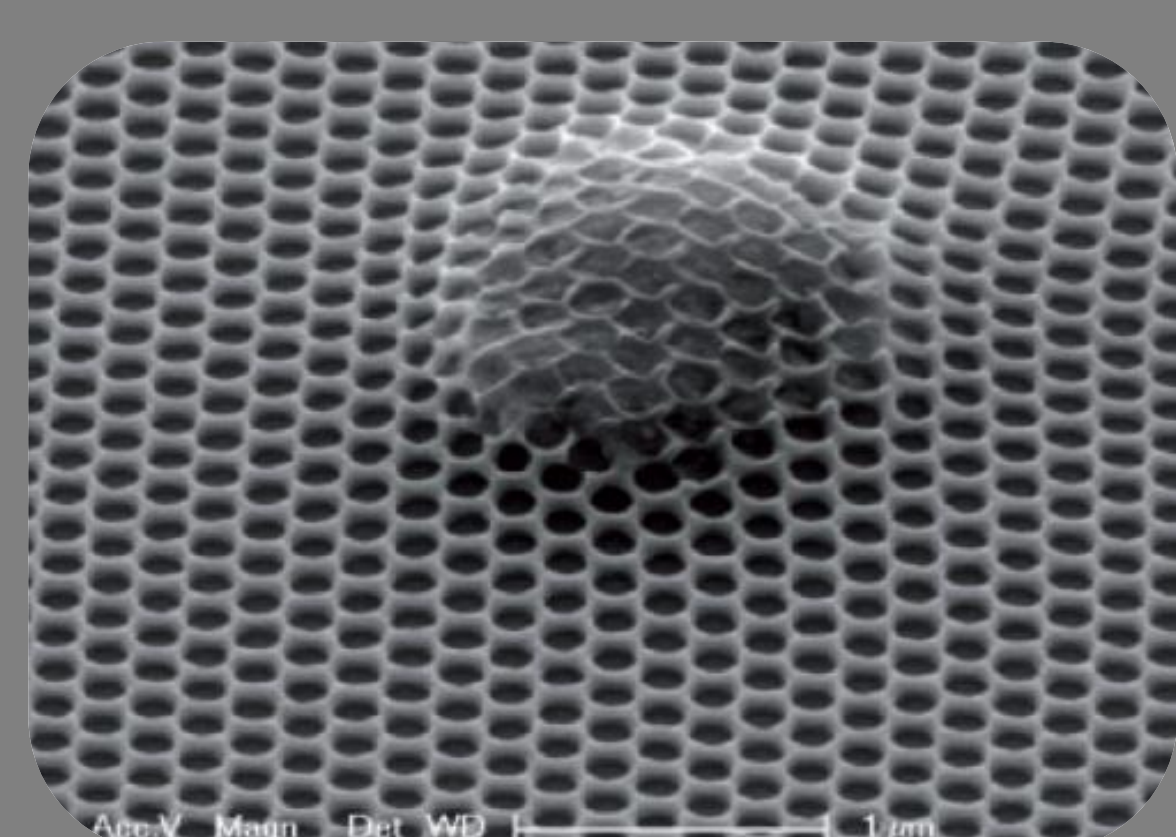
Your gateway to multimaterial micro- and nanotechnologies

- 36 installations
- 75 processes
- 60 technology experts

Your Benefits

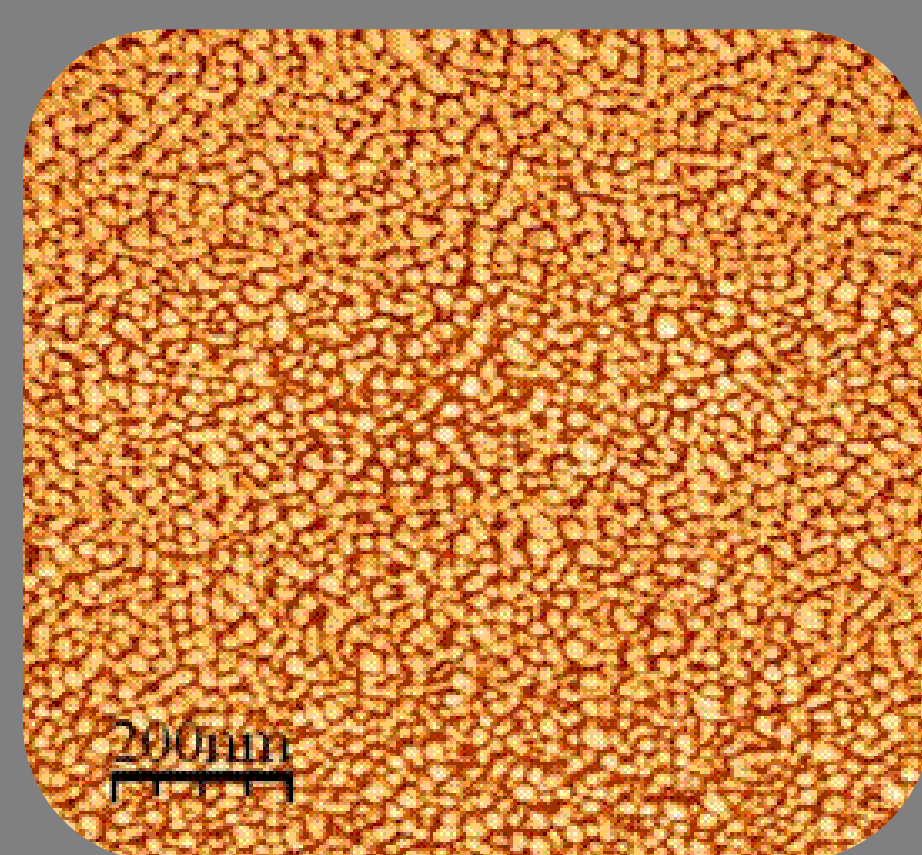
- Open access costs covered by the FP7 funding
- Efficient solutions in multimaterial micro- and nanofabrication
- Discuss your ideas with technology experts
- Test and evaluate new technologies for your applications

Micro Nano Patterning



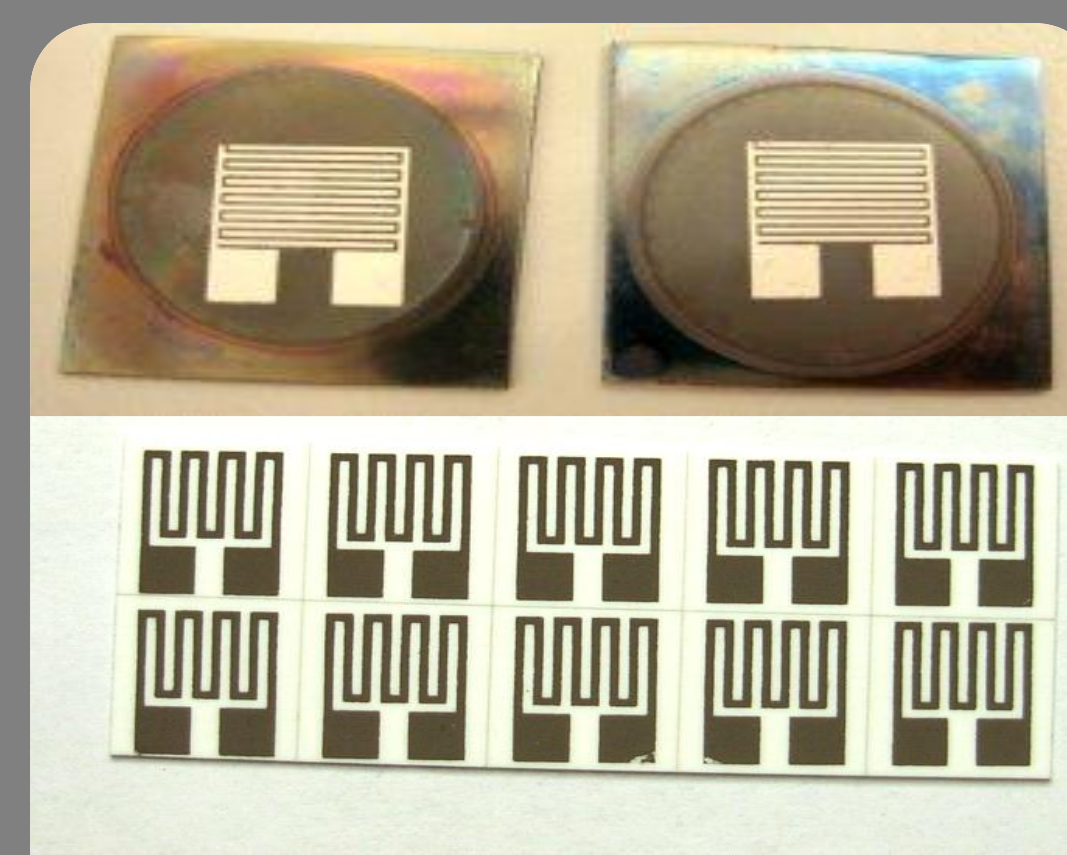
Nano printing on curved surfaces.
© Philips MiPlaza

Thin film deposition



PVD nanoparticle deposition.
© CEA Liten

Replication



Screen printed Ni on alumina
and Ag on porous titania for
gas sensors.
© Centro Ricerche FIAT

Characterisation



Metrological atomic force
microscopy.
© NPL

Submit your proposal

www.euminafab.eu

Contact User Office

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